

APR 27 2004

*Smale*  
500.41254X00



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: MIZUMURA et al

Serial No.: 10/080,540

Filed: February 25, 2002

For: Etching Method Of Organic Insulating Film

Art Unit: 1765

Examiner: S. Ahmed

**STATEMENT OF SUBSTANCE OF INTERVIEW**

Mail Stop: Issue Fee  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

April 27, 2004

Sir:

The following statement of the substance of the telephonic interview conducted between the Examiner and the undersigned on April 1, 2004 is being submitted in reply to the requirement in the Interview Summary mailed with the Notice of Allowance on April 19, 2004.

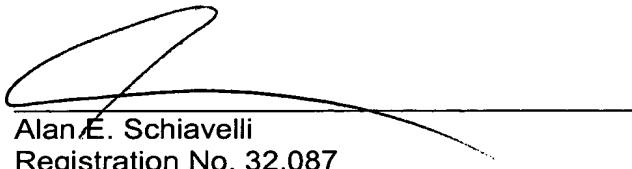
The Examiner's statement of the substance of the interview in the Interview Summary is complete and correct.

To the extent necessary, applicants petition for an extension of time under 37 CFR 1.136. Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli,

Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case: 500.41254X00),  
and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP



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